

Valutazione di materiali ceramici sottili per circuiti ibridi per l'upgrade del tracciatore di LHCb

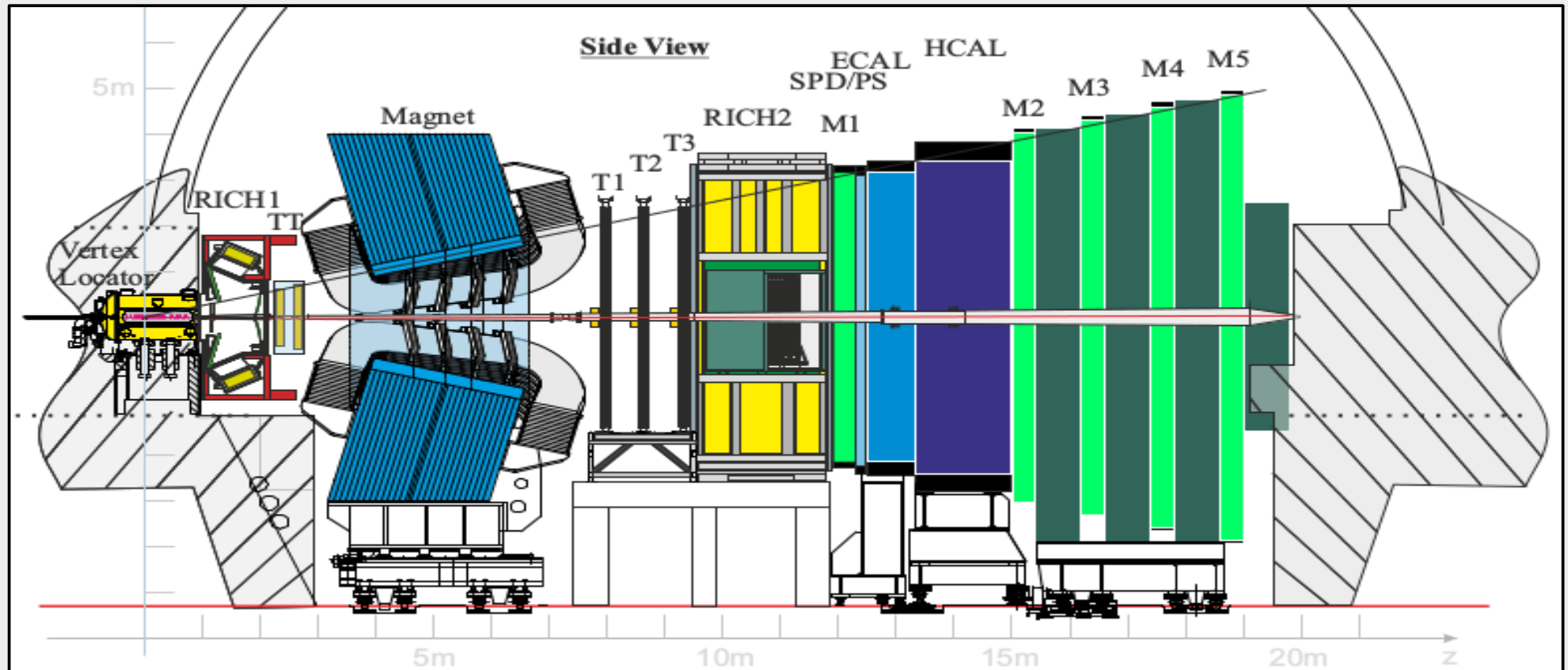
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Ciclo XXX

Workshop di fine anno
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LHCb experiment

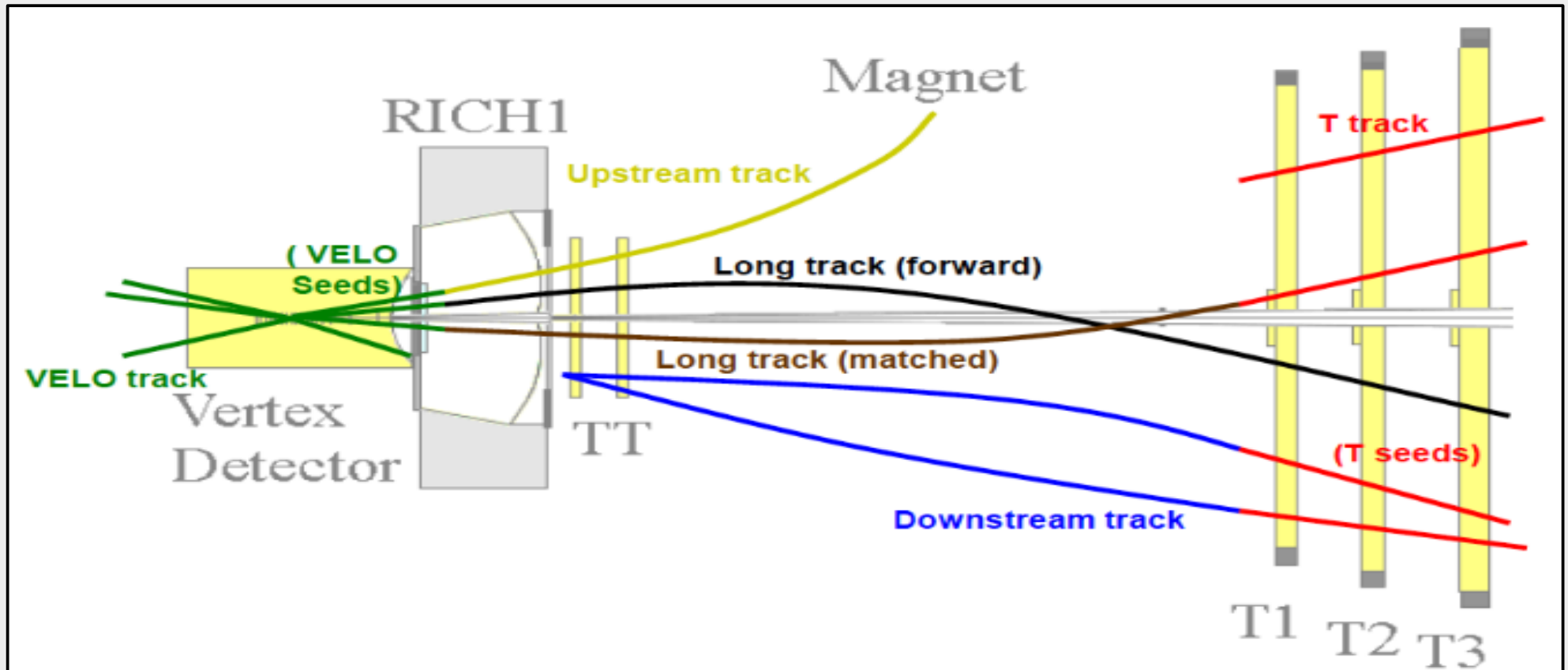


Forward spectrometer experiment at the LHC for studies of CP violation and rare decays of b hadrons

Excellent results already achieved:

- few results in tensions with Standard Model (e.g.: $b \rightarrow s l^+ l^-$ transitions, tauonic $B \rightarrow D^* \tau \nu$ decays)
- first observation of rare $B_s^0 \rightarrow \mu^+ \mu^-$ decay productions
- discovery of tetraquark and pentaquark
- obtained world best measurements in heavy flavour physics

LHCb tracking system



Vertex Locator → measures particle trajectories near the proton-proton interaction point

Tracker Turicensis (to be upgrade with Upstream Tracker) → placed upstream of the magnet

T-Stations → measures particle interactions downstream of the magnet

LHCb Upgrade

Precision measurements of LHCb are **limited by statistical error**

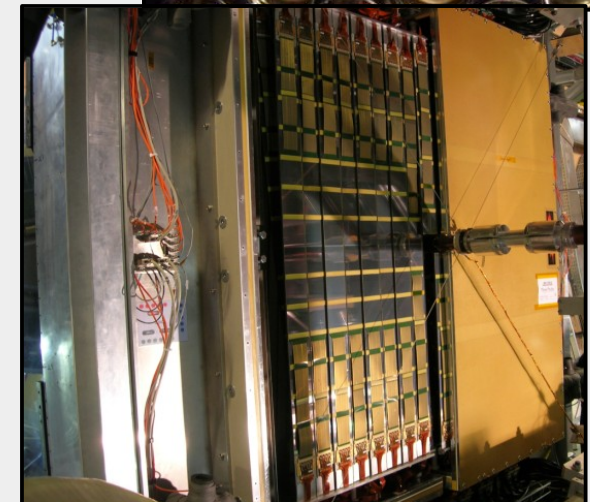
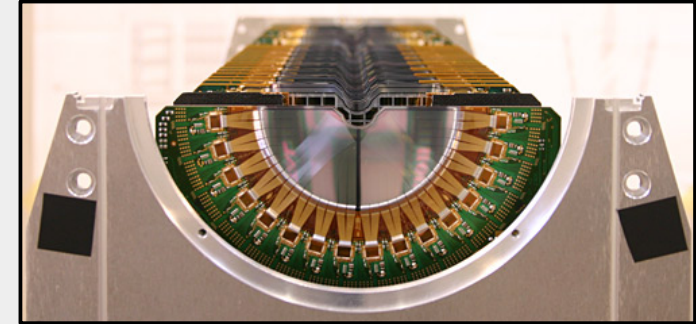
Much **higher statistics** needed

Need to upgrade the detector to cope with **high particle rates**

Expected **increase of signal yield** at least one order of magnitude

New detectors, new read-out electronics, new trigger scheme

Read out the entire event at each bunch crossing, **every 25ns**
(not possible at the moment)



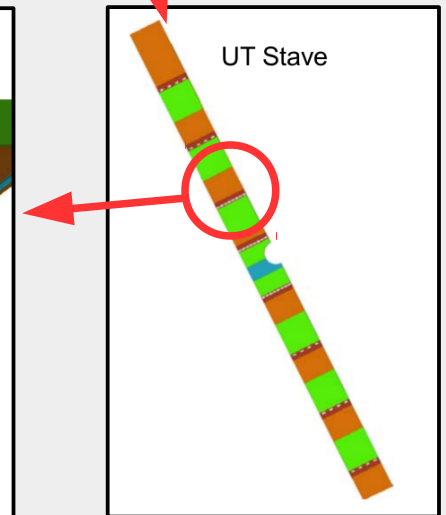
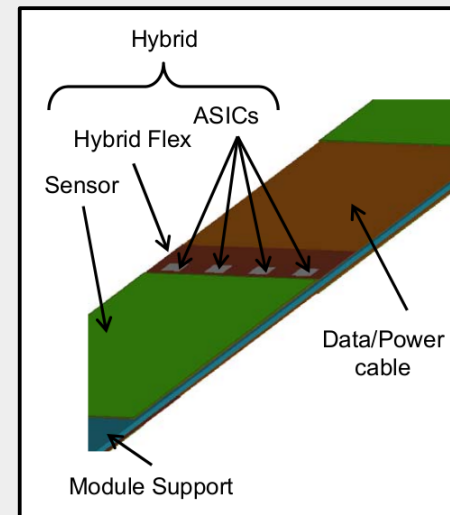
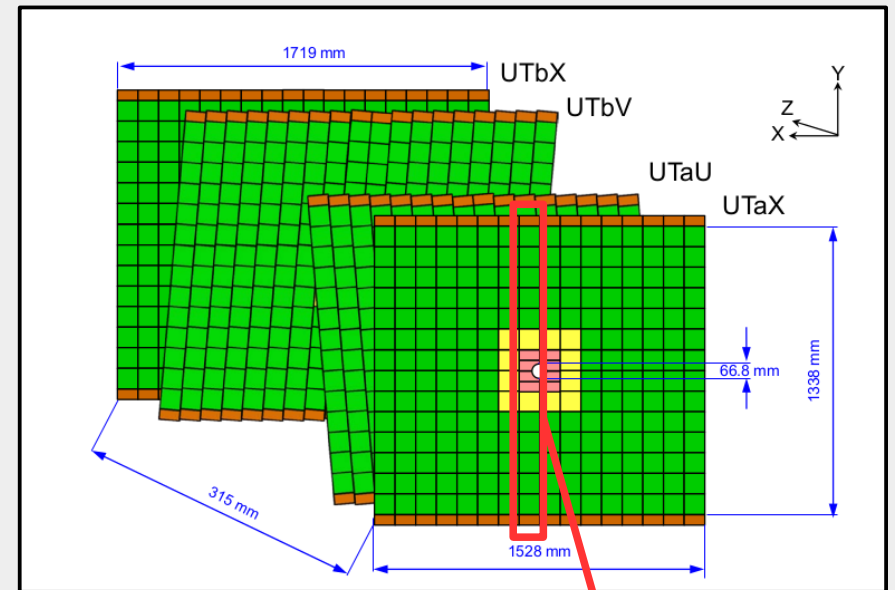
Upstream Tracker upgrade

Upgrade of the **silicon strip tracker** positioned upstream of the magnet

Crucial detector of the LHCb tracking system

UT conceptual design:

- **4 planes** of silicon strip sensors
- Finer granularity near the beam pipe
- Overlap between sensors to **avoid gaps in acceptance**
- radiation-hard silicon sensors to **resist to high radiation dose** (up to 40MRad)
- **New front-end electronics** for 40MHz read-out scheme



Main Challenges in UT design

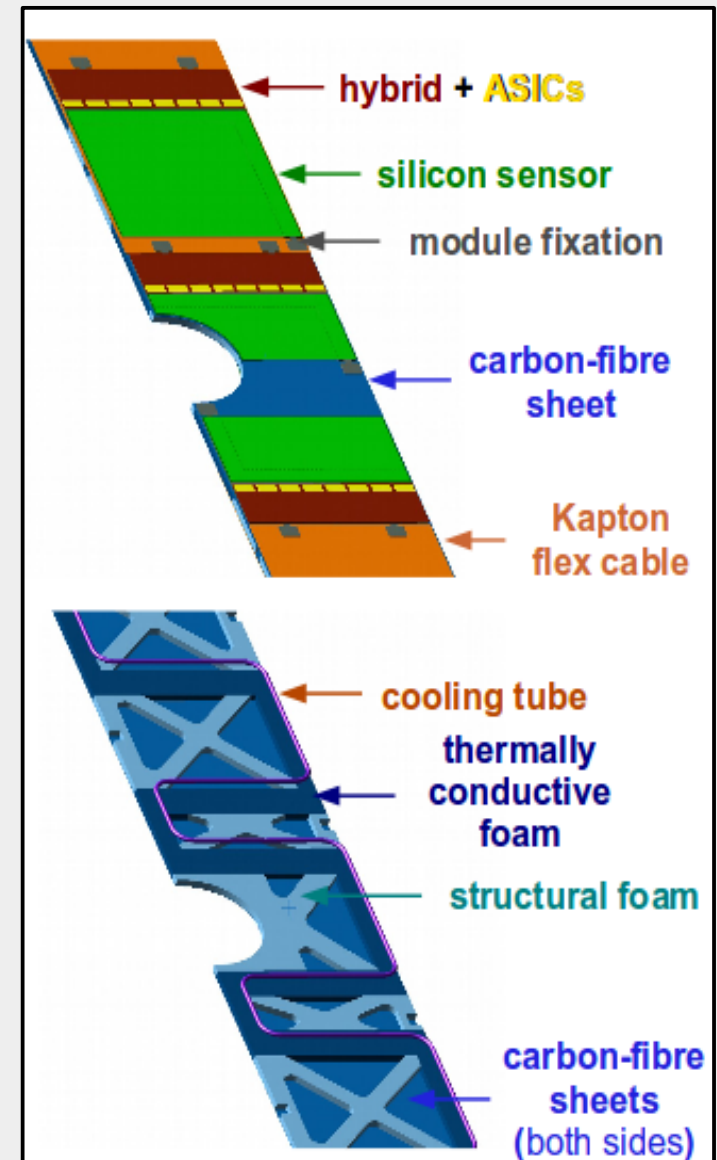
High efficiency detector → high signal over noise (~20)

Low material budget → thin and compact materials
(250 μ m thickness)

High precision detector → high granularity (90-180 μ m pitch)
→ high number of channels (~500K)
→ complex read-out electronics

Resistant to radiation → need to operate at -5° to reduce
the effects of radiation damage

Efficient cooling system → evaporative CO₂ system
→ cooling tubes under the electronics
→ capable to operate until -30°C

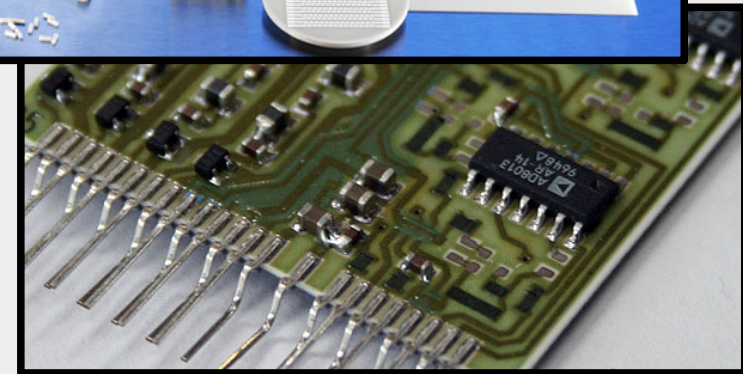
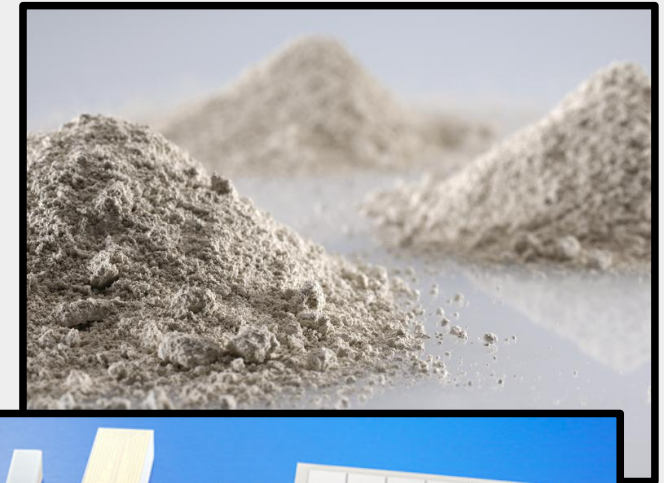


Ceramic materials for applications to silicon sensors

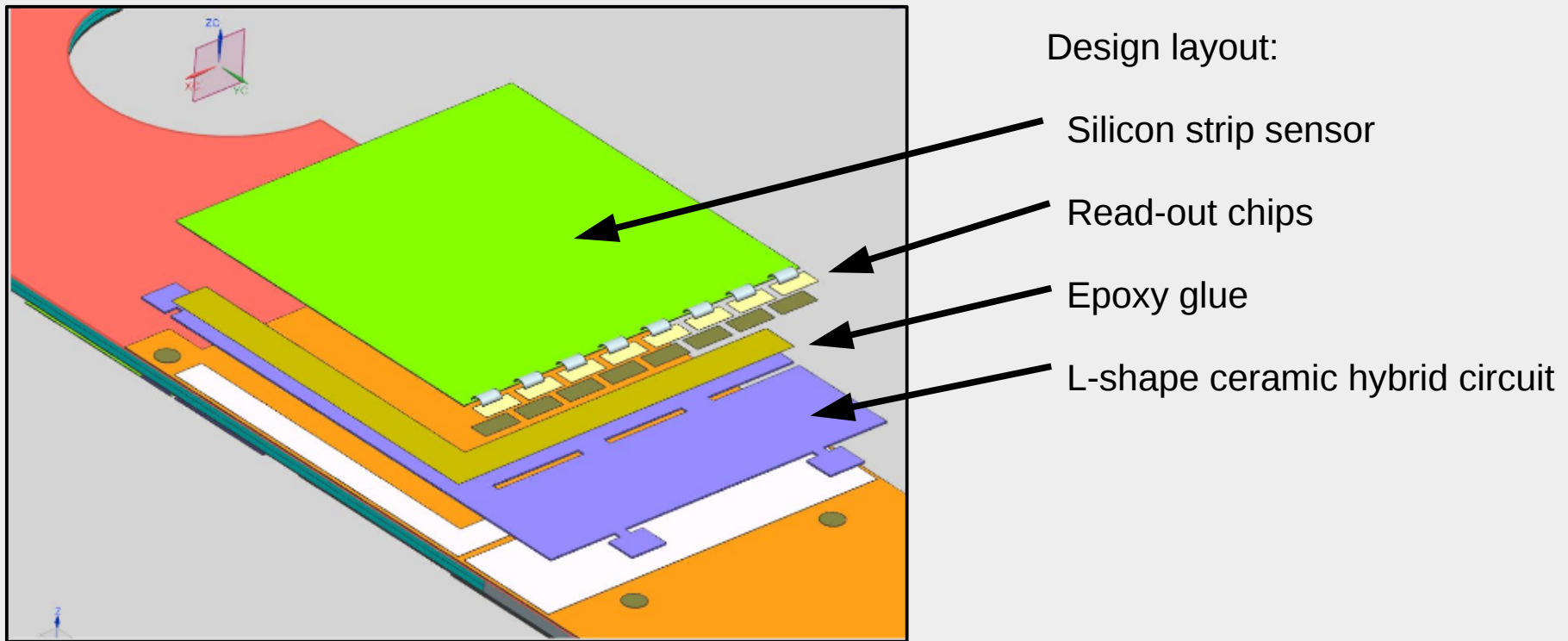
Ceramic materials provide:

- high **thermal conductivity** ($\sim 150 \text{ W/(m.K)}$)
- **precise mechanical layout** ($\sim O(10\mu\text{m})$)
- excellent **electrical insulation**
(dielectric strength $\sim 17\text{KV/mm}$)
- excellent **resistance to radiation** (up to 40MRad)

These features are very interesting for
applications in detector construction



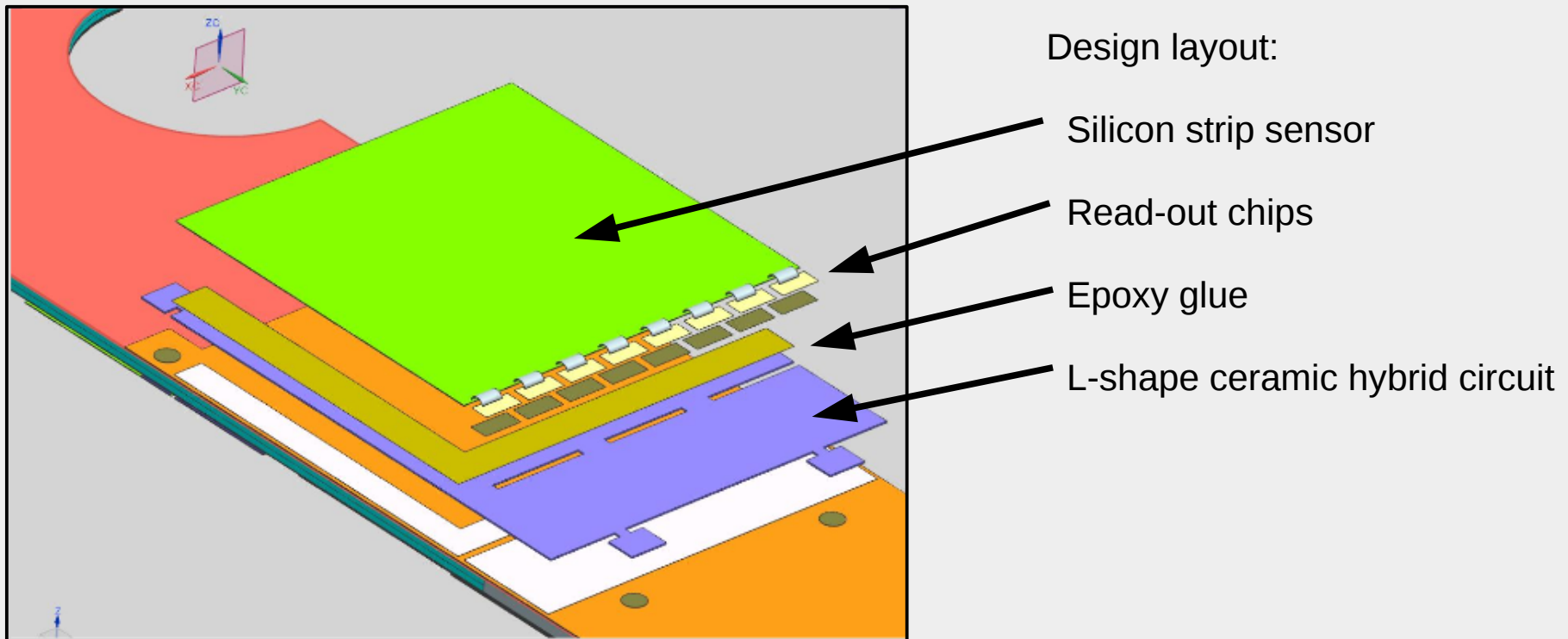
Ceramic hybrid circuit for UT sensor modules



Innovative solution, based on **advanced ceramic** materials allows compact module design :

- **Mechanical support** for sensor and front-end chips
- Efficient **thermal bridge** between cooling system and sensor
- **Electronic circuitry** for read-out system
- **Low material** budget using reduced ceramic thickness

Ceramic hybrid circuit for UT sensor modules



Different ceramic materials under investigation:

- **Aluminum Nitride:** **standard** ceramic for electronic circuits
well assessed technology
- **Pyrolytic Boron Nitride:** better mechanical properties
non standard material for electronic circuitry
R&D is required

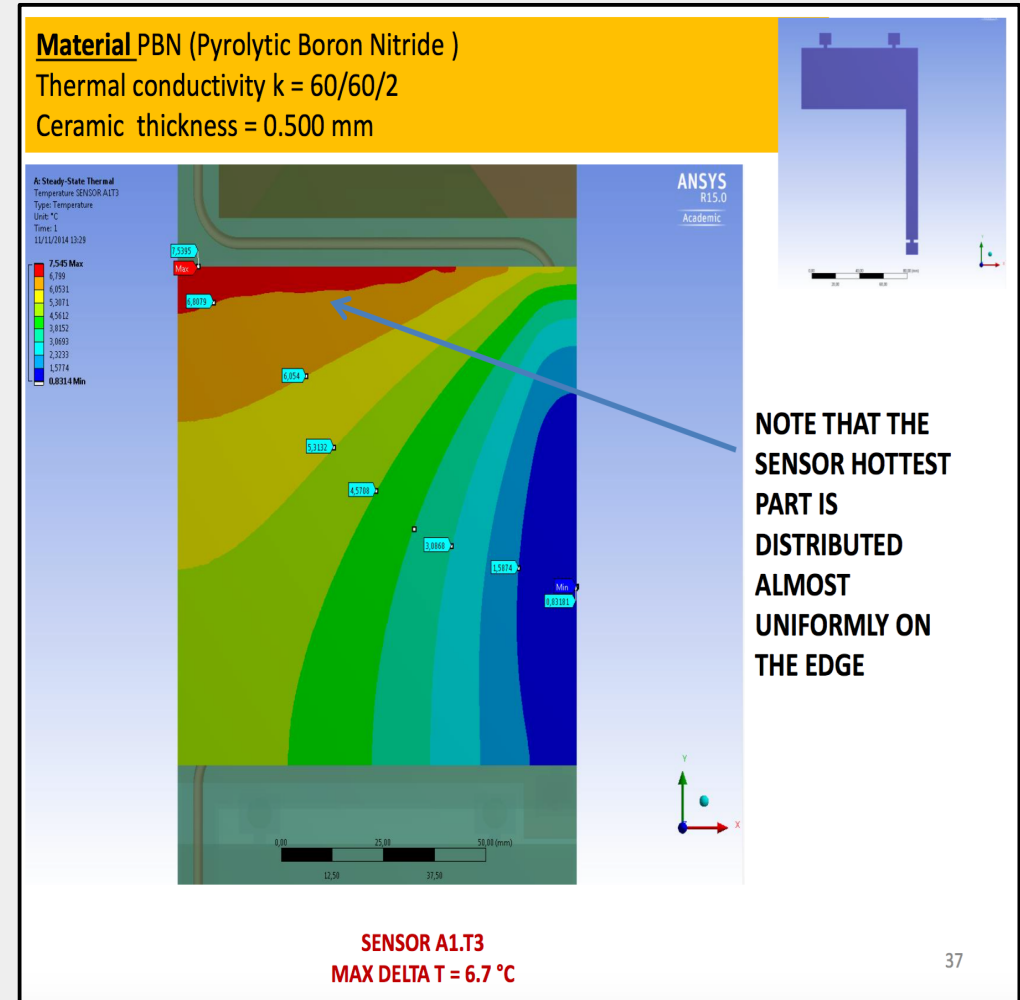
Thermal simulations

Thermal simulation to evaluate the **heat distribution** over the sensors:

- Red region is near the read-out chip
- Blue region is above the cooling pipe
- **AlN and PBN simulated**
- **Both show similar behaviour**

Thermomechanical simulations show **~100um deformation** along the plane axis:

- sensor is glued along to sides only
- **does not represent a problem**



Mechanical measurements on ceramic mechanical prototypes

Optical metrological measurements, performed on mechanical prototypes:

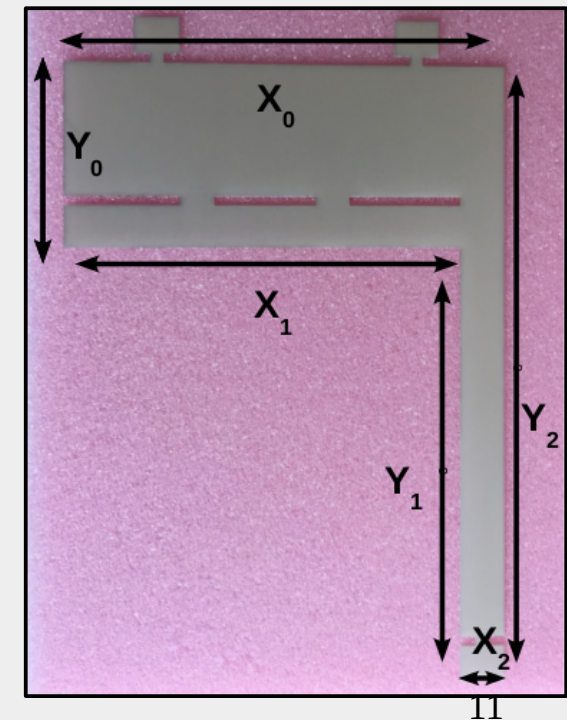
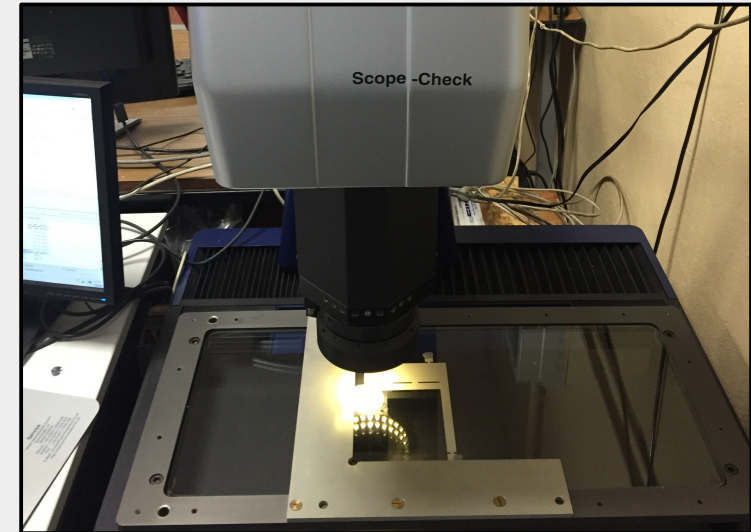
- at **ambient** temperature (20°C)
- at **nominal working** temperature (-5°C)

Planarity measurements:

- Measure **vertical coordinate** as a function of the position on the ceramic surface

Good mechanical properties:

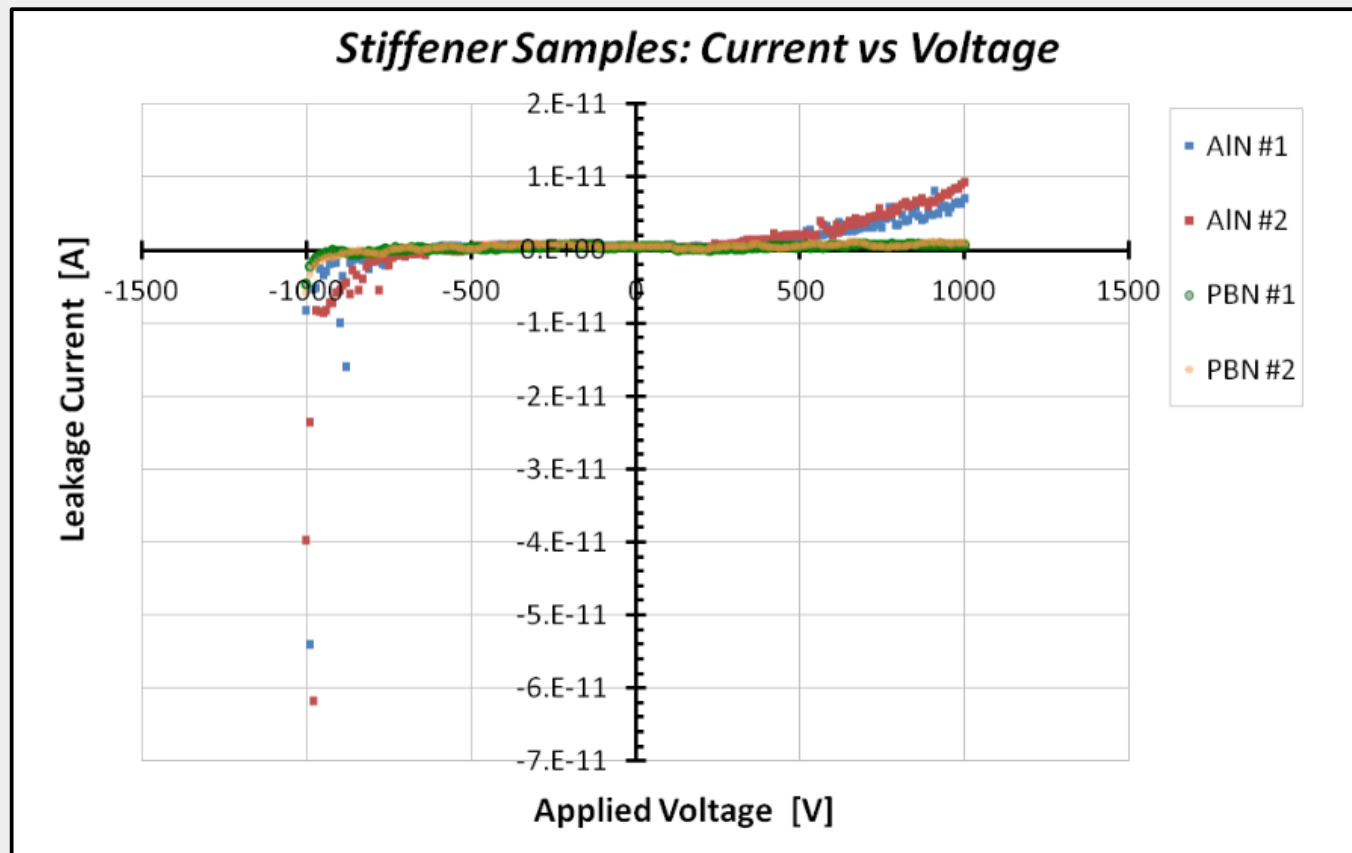
- **No evident deformations** of the system (<10μm)



Irradiation test of Aluminum Nitride and Pyrolytic Boron Nitride ceramic

Tests on different prototypes :

- Samples irradiated at 40MRad with ^{60}Co γ -rays
- **Extremely low leakage currents** (<10pA at 500 V)
- **Both prototypes satisfy** electrical insulation requirements



Thick-film technology for electronic circuitry on ceramic

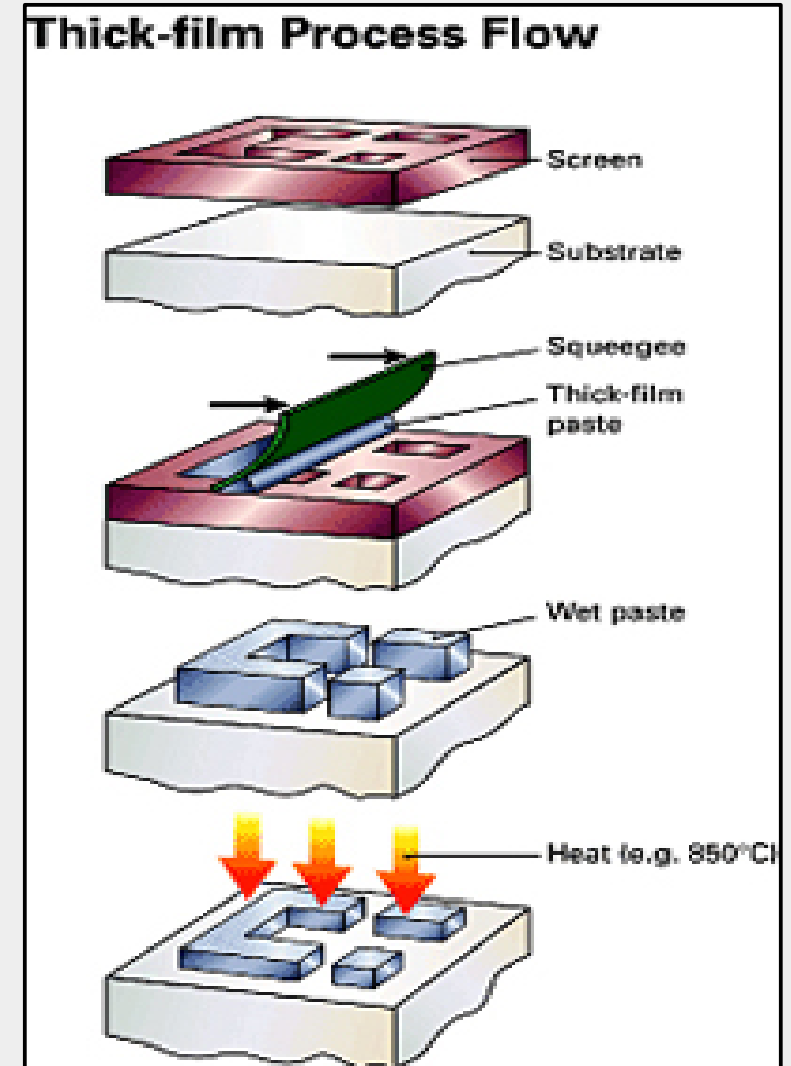
Implementation of **electronic circuitry** on ceramic is possible using the “**thick-film**” technology

A **mask** is used to apply **conductive or dielectric pastes** on the substrate to produce the desired layout

The **mask is removed by evaporation** at 50-200°C

The **paste is fixed to the substrate** by heating at higher temperatures (~800 °C)

The process is **repeated for multiple layers**



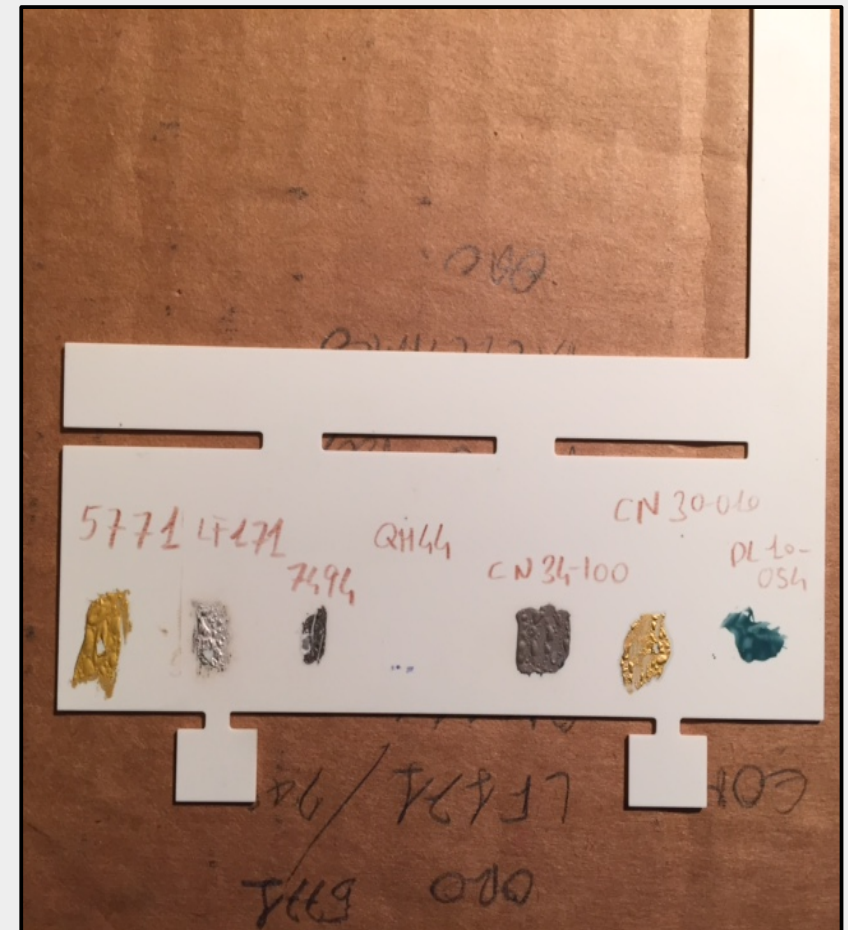
Test of thick-film technology on Pyrolitic Boron Nitride

Production of **electronic circuitry on Pyrolitic Boron Nitride** is not a standard industrial process

Although, Pyrolitic Boron Nitride shows **better mechanical and radiation-hardness properties**

Different kind of **pastes are under investigation to verify the feasibility** of the hybrid circuit construction on this ceramic

At the moment **none of the tested pastes satisfies** the requirements



Future work and conclusions

This work is part of a **large effort for the upcoming LHCb upgrade** that will improve the data taking capabilities and it is **crucial to complete the scientific program** of the experiment

Preliminary results show that **ceramic hybrid circuit is a viable solution for the UT sensor modules**

Next steps:

Design of the first hybrid circuit, **production of a prototype** and **characterization**

- Test of **thermomechanical properties**
- **Characterization after proton irradiation** at 40MRad (@ IRRAD, CERN) :
- **Integration** with silicon sensor and read-out electronics
- **Validation of the prototype** results and approval for construction
- **Large scale production** for application in the LHCb experiment

Thanks!